

Notice of References Cited	Application/Control No. 10/596,944		Applicant(s)/Patent Under Reexamination MAZIASZ ET AL.	
	Examiner PATRICK SANDOVAL		Art Unit 2825	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-6,209,123 B1	03-2001	Maziasz et al.	716/14
*	C	US-6,351,841 B1	02-2002	Tickle, Andrew C.	716/8
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	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Wang, L. Y. et al., "Topological cell compaction via transistor rotation", 1991, Circuits and Systems, Vol. 2, Pages 909-912.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.